

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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1756

In re PATENT APPLICATION of

Inventor(s): JASPER

Atty.Dkt: 81468/257643

Appln. No.: 09/519,875

Filed: March 6, 2000

FOR: OFF-AXIS LEVELING IN LITHOGRAPHIC PROJECTION APPARATUS



Group Art Unit:

Examiner:

Date: March 21, 2000

IDS LETTER CITING APPLICATION

The Examiner's attention is directed to the following application of:

Examiner's Initials*	FIRST INVENTOR (Last Name Only)	APPLICATION NO. (Series Code/Serial No.)
	KRUIZINGA	09/521,599

PLEASE DO NOT PRINT the above information on the patent which results from the subject application.

This application is being filed within three months of the application filing date.

Consideration of the listed application is earnestly solicited since unpublished patent applications are contemplated as IDS material; see the exception in Rule 98(a)(ii) and note the penultimate sentence of MPEP 609.

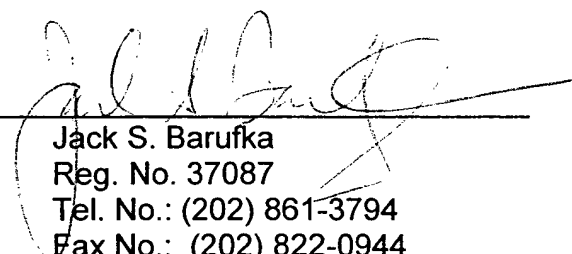
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Further, in keeping with MPEP 609, Subsec. C(2), 2nd para., line 10 to end of the paragraph (especially note lines 18-25) **PLEASE RETURN A COPY OF THIS LETTER** with the Examiner's initials adjacent the above listing so that applicant will know that the listed application has been considered as required by PTO policy. Thanks.

Respectfully submitted,

PILLSBURY MADISON & SUTRO LLP

By



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*The Examiner's initials adjacent a citation indicates he/she has considered the cited application relative to the subject application.

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In re PATENT APPLICATION of

JASPER et al.

Appln. No.: 09/519,875

Filed: March 6, 2000

Title: OFF-AXIS LEVELING IN LITHOGRAPHIC PROJECTION
APPARATUS



Group Art Unit:

Examiner:

7/7/00
#261DS

March 21, 2000

* * * * *

INFORMATION DISCLOSURE STATEMENT

Attached is Form PTO-1449 listing the enclosed document.

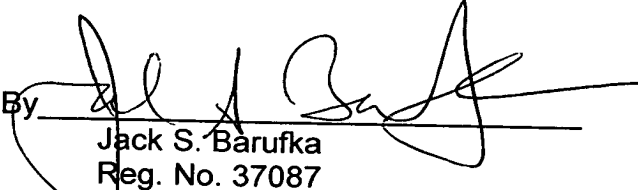
This IDS is being filed within three months of the application filing date.

This IDS is intended to be in full compliance with the rules, but should the Examiner find any part of its required content to have been omitted, prompt notice to that effect is earnestly solicited, along with additional time under Rule 97(f), to enable Applicant to comply fully.

Consideration of the foregoing and enclosures plus the return of a copy of the enclosed Form PTO-1449 with the Examiner's initials in the left column per MPEP 609 are earnestly solicited along with an early action on the merits.

Respectfully submitted,

PILLSBURY MADISON & SUTRO LLP

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Atty. Dkt. No.	M#	Client Ref.
257643		P-0128.010-US

**INFORMATION DISCLOSURE STATEMENT
BY APPLICANT**

Applicant: Jasper et al.

Appln. No.: 09/519,875

Filing Date: March 6, 2000

Date: March 21, 2000

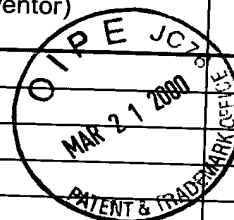
Page 1 of 1

Examiner: not assigned

Group Art Unit: not assigned

U.S. PATENT DOCUMENTS

Examiner's Initials*	Document Number	Date MM/YYYY	Name (Family Name of First Inventor)	Class	Sub Class	Filing Date (if appropriate)
PK	AR 5,144,363	09/1992	Wittekoek			
PK	BR 4,540,277	09/1985	Mayer			
PK	CR 5,748,323	05/1998	Levinson			
PK	DR 5,191,200	03/1993	van der Werf			
	ER					
	FR					
	GR					
	HR					
	IR					
	JR					
	KR					
	LR					
	MR					
	NR					



FOREIGN PATENT DOCUMENTS

	Document Number	Date MM/YYYY	Country	Inventor Name	English Abstract	Translation Readily Available
					Enclosed	No
PK	OR EP0951054	10/1999	Europe	Nishi		x
PK	PR EP0466445	10/1992	Europe	Dirk		x
PK	QR WO 99/32940	07/1999	Europe	Loopstra		x
PK	RR WO 99/28790	06/1999	Europe	Loopstra		x
PK	SR WO 98/39689	09/1998	Europe	Bornebroek		x
	TR					
	UR					
	VR					
	WR					
	XR					

OTHER (Including in this order Author, Title, Periodical Name, Date, Pertinent Pages, etc.)

YR	
ZR	
AAR	
BBR	
CCR	
DDR	

Examiner

Date Considered:

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.